



(He Jishu)

目 次

2010 全国荷电粒子源、粒子束学术会议专刊 (大连, 2010.6.30-7.3)

电子束表面改性对变形镁合金 AZ31 结构和性能的影响 曹辉 郝仪 张文凤 高波 涂贻峰 等 (881)

强流脉冲电子束处理对过共晶铝硅合金 Al-25Si 微观组织和耐蚀性的影响
 郝仪 高波 涂贻峰 李世伟 郝胜智 等 (886)

加速器联机装置运行状况 刘传胜 黎明 何俊 杨铮 周霖 等 (891)

电子束共辐照接枝改性聚醚砜微孔膜 韩兆磊 孟凡霞 王永霞 刘晓光 王荣 (898)

Zn 离子注入增强 TiO₂ 纳米管光电效应 梁宏 廖斌 马芙蓉 吴先映 张旭 等 (903)

多靶磁控溅射系统磁场优化设计 庞恩敬 朱颖 李芬 李刘合 卢求元 等 (908)

等离子与激光复合热源喷涂 WC-CoCr 涂层组织性能研究 李淑青 巩水利 李其连 (913)

IBAD 和磁控溅射对银膜性能的影响 金杰 邱维维 王锦辉 郭会斌 (918)

等离子浸没离子注入陡脉冲前后沿效应及控制技术 朱宗涛 桂刚 汪志键 巩春志 杨士勤 等 (923)

低真空中高能电子束传输特性的 MC 模拟 栾希亭 邓永锋 谭畅 韩先伟 毛根旺 (928)

关于强流 ECR 质子源氢等离子体发射光谱的诊断研究 冯哲 张小章 刘占稳 赵红卫 (933)

氢氦离子注入机的研制 陈立华 崔保群 马瑞刚 郑永男 姜冲 等 (937)

用锥形玻璃毛细管聚焦获取 MeV 能量 He⁺微米离子束 龚知宇 颜莎 马宏骥 聂锐 薛建明 等 (941)

样品温度对 SiF₃⁺与 SiC 表面相互作用影响的分子动力学研究 贺平逆 吕晓丹 赵成利 苟富均 (945)

高功率脉冲非平衡磁控溅射制备 CrN_x 薄膜及其性能研究 牟晓东 牟宗信 王春 臧海荣 刘冰冰 等 (951)

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Contents

A special issue for Symposium on Charged Particle Sources and Beams (Dalian, June 30–July 3, 2010)

- Effect of HCPEB surface modification on microstructure and properties of wrought Mg alloy AZ31
..... CAO Hui HAO Yi ZHANG Wenfeng GAO Bo TU Ganfeng *et al* (881)
- Microstructure and corrosion resistance of HCPEB-treated hypereutectic Al-25Si
..... HAO Yi GAO Bo TU Ganfeng LI Shiwei HAO Shengzhi *et al* (886)
- Accelerator-TEM interface facility and application
..... LIU Chuansheng LI Ming HE Jun YANG Zheng ZHOU Lin *et al* (891)
- Graft-copolymerization of polyethersulfone microporous membrane with electron beam simultaneous irradiation method
..... HAN Zhaolei MENG Fanxia WANG Yongxia LIU Xiaoguang WANG Rong (898)
- Enhanced photoelectric effect of TiO₂ nanotube arrays modified by Zn implantation
..... LIANG Hong LIAO Bin MA Furong WU Xianying ZHANG Xu *et al* (903)
- Optimal design of the magnetic field in a multi-target magnetron sputtering system
..... PANG Enjing ZHU Ying LI Fen LI Liuhe LU Qiuyuan *et al* (908)
- Microstructure and performances of the WC-10Co4Cr coatings deposited by laser hybrid plasma spraying technology
..... LI Shuqing GONG Shuili LI Qilian (913)
- Microstructure and properties of silver films obtained using ion beam composite deposition
..... JIN Jie QIU Weiwei WANG Jinhui GUO Huibin (918)
- The reduction of leading- and trailing-edge of high-voltage steep pulse in plasma immersion ion implantation
..... ZHU Zongtao GUI Gang WANG Zhijian GONG Chunzhi YANG Shiqin *et al* (923)
- Monte Carlo simulation of electron beam transportation characteristics under low-vacuum condition
..... LUAN Xiting DENG Yongfeng TAN Chang HAN Xianwei MAO Genwang (928)
- OES diagnostics of H₂ plasma in an intense ECR proton source
..... FENG Zhe ZHANG Xiaozhang LIU Zhanwen ZHAO Hongwei (933)
- A 200 keV H₂⁺/He⁺ ion implanter CHEN Lihua CUI Baoqun MA Ruigang ZHENG Yongnan JIANG Chong *et al* (937)
- Using tapered glass capillary to focus 2 MeV He⁺ ion beam into microbeam
..... GONG Zhiyu YAN Sha MA Hongji NIE Rui XUE Jianming *et al* (941)
- MD study on temperature effects of SiF₃⁺ etching SiC surfaces HE Pingni LV Xiaodan ZHAO Chengli Gou Fujun (945)
- Study on deposition and properties of CrN_x films by high power pulsed unbalanced magnetron sputtering
..... MU Xiaodong MU Zongxin WANG Chun ZANG Hairong LIU Bingbing *et al* (951)